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U.S.S.N. 10,813,785

JUN 19 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Chou et al.

Group Art Unit: 1763

Serial No.: 10,813,785

Examiner: Olsen, Allan W.

Filed: 03/30/2004

In Response to Office Action

Dated: 03/22/2006

For:

PROCESS FOR REDUCING PARTICLE FORMATION DURING ETCHING

Attorney Docket No.: 67,200-1164(2002-0954)

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TUNG & ASSOCIATES 838 W. Long Lake Road, Suite 120 Bloomfield Hills, MI 48302 U.S.S.N. 10,813,785

## Response to Office Action

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 03/22/2006 please enter the following amendments and consider the following remarks.